

Carbon Velvet Cathodes

NRL Workshop on Cathodes for Relativistic Electron Beams

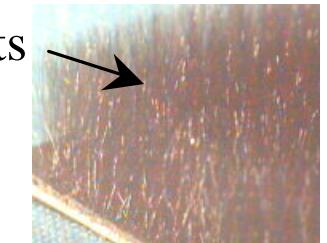
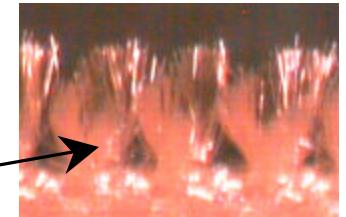
Timothy R. Knowles, Energy Science Laboratories, Inc.
tknowles@esli.com

Contents

- Heritage
- Design Considerations
- Cathode Types Fabricated
 - NRL, PLK
- Materials Options
- Benefits

Velvet Cathode Heritage

- Explosive emission cathodes for HPM, HEL
 - Conditions 0.1-1 MV, ~kA/cm², ~0.1 μs, <1 Hz
 - Requirements high current, fast turn on, uniformity, long pulse duration, long cycle life, (large, conformal, lightweight)
- Heritage
 - 1980's: carbon felts, carbon fibers, cloth velvets
 - Prohaskar&Fisher, Eden&Epp, Erickson&Mace, Adler&Voss, ...
 - Achieved uniform fast current ... but duration, lifetime, consistency of velvet, were lacking
 - 1990's: carbon tufts, photoemitting salts, carbon velvets
 - Garate et al., Benford, Bekefi&ESLI
 - Achieving better duration, uniformity, cycle life



Design Consideration

- Provide field enhancement
 - Two enhancement effects
 - Velvet field concentration

$$\beta_{velvet} = 1/f$$
 - Fiber field enhancement

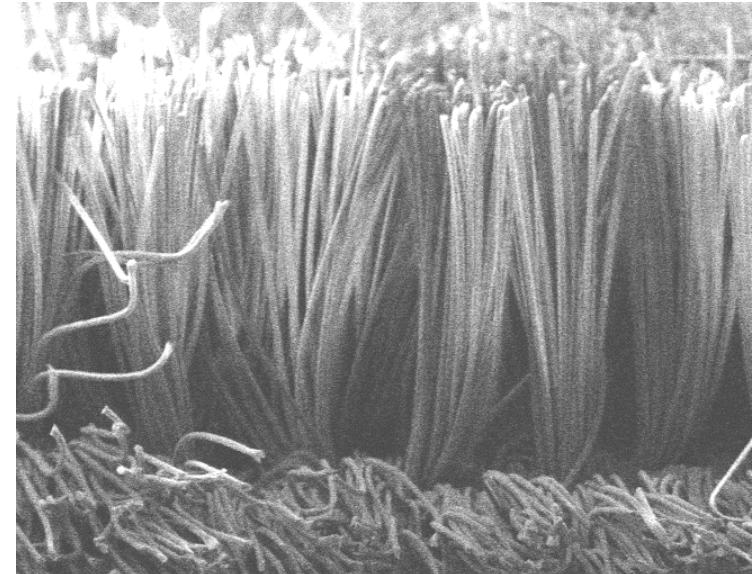
$$\beta_{fiber} = 2L/D$$
- Balanced design requires
 - Velvet not too dense
 - Fibers not too short
- But ... really relevant to explosive emission?

Examples	units	1.00E+09	1.00E+10
field strength required	V/m	1.00E+09	1.00E+10
voltage	V	5.00E+05	5.00E+05
gap	m	2.00E-02	2.00E-02
gap field strength enhancement required	V/m	2.50E+07	2.50E+07
	-	40	400
maximum fiber packging	-	2.50%	0.25%
minimum fiber aspect ratio	-	20	200
fiber diameter	m	7.00E-06	7.00E-06
minimum fiber length	m	1.40E-04	1.40E-03

β field enhancement factor
 ϕ fiber packing fraction
 L fiber length
 D fiber diameter

Compare Velvet Structures

- ESLI Carbon-Carbon
 - 7-mu dia @ 2.0%
- NRL Green Polymer
 - 18-mu dia. @ 4.4%



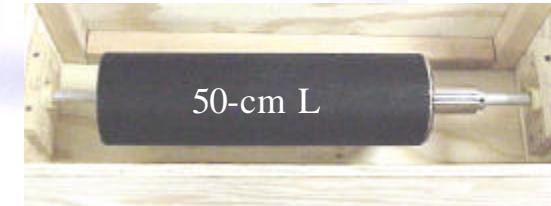
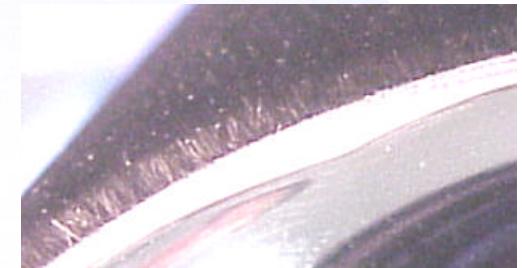
Carbon Velvet Cathodes (1999)

- Flexible fabric configuration with vinyl substrate
 - Substrate options: epoxy; metal?
- Discrete PAN Carbon Fiber, Ag-epoxy, on Al substrate
 - Investigated fiber packing densities 0.1 - 2.0 %
 - 2.5e5 shots @ 330 kV, 3.3 kA, 1 μ s (D. Shiffler, 2Feb01)



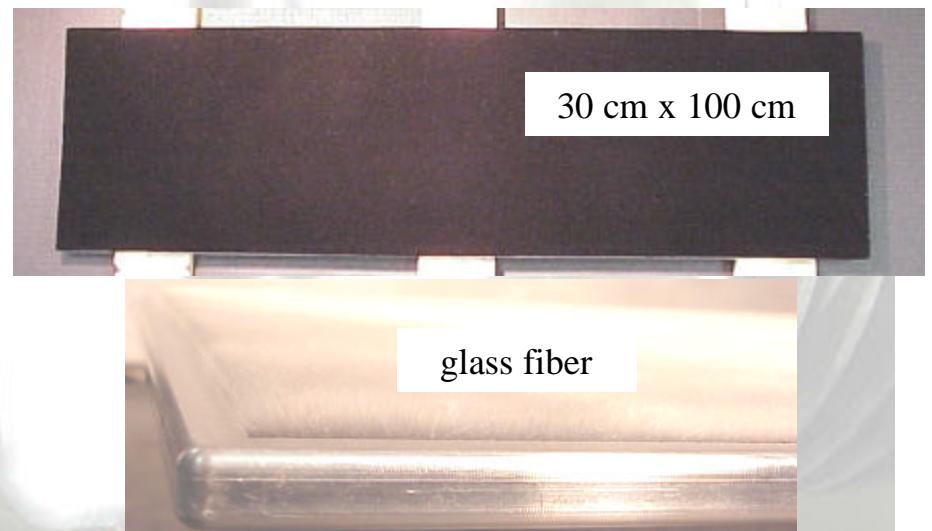
MILO Cathodes (2000)

- ESLI Carbon Fiber/Epoxy/Aluminum
 - 1.5-mm velvet at 0.4%(vol); 1 kA/cm² @500 kV



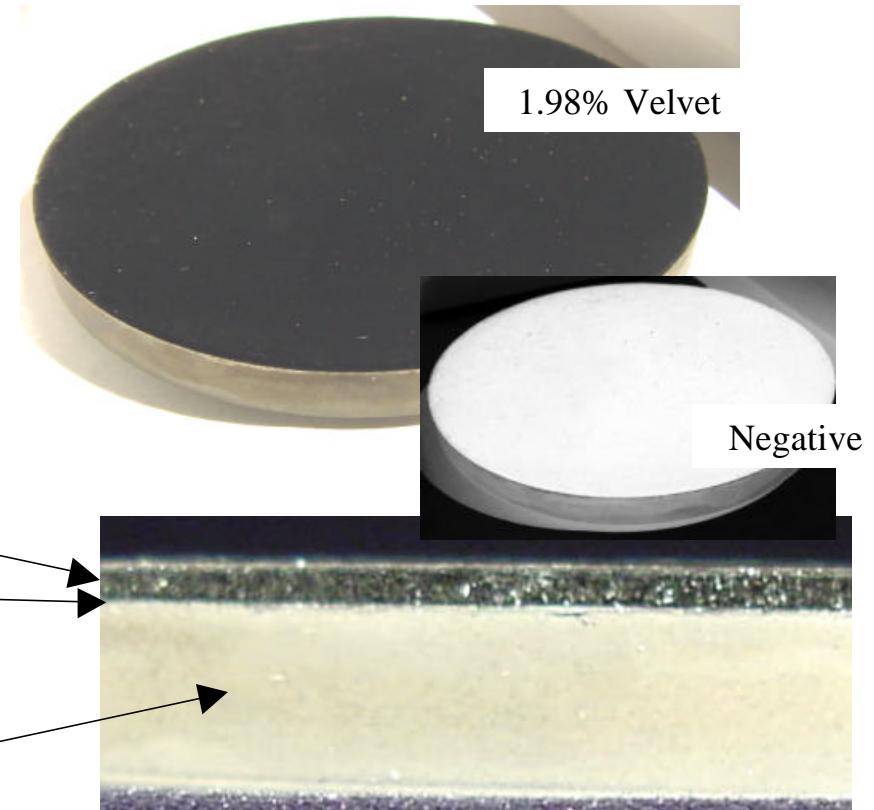
ELECTRA Cathodes (2000)

- Carbon Fiber/Epoxy/Aluminum
 - 1.5-mm high-k PAN @2.0% and @1.6%
 - Best uniformity of all cathodes
 - Good turn-on time
 - Limited lift testing OK
 - Minimal debris



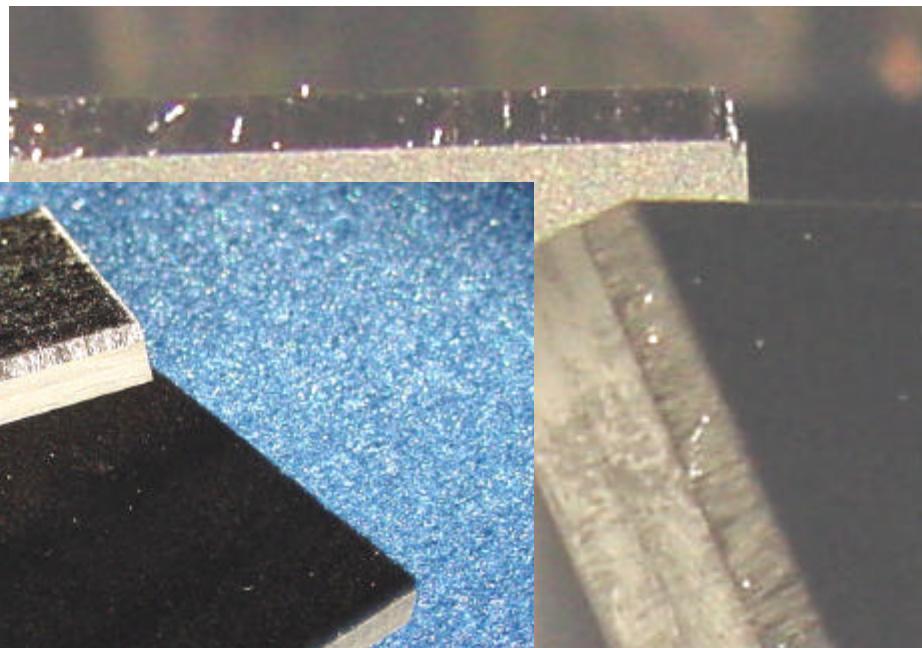
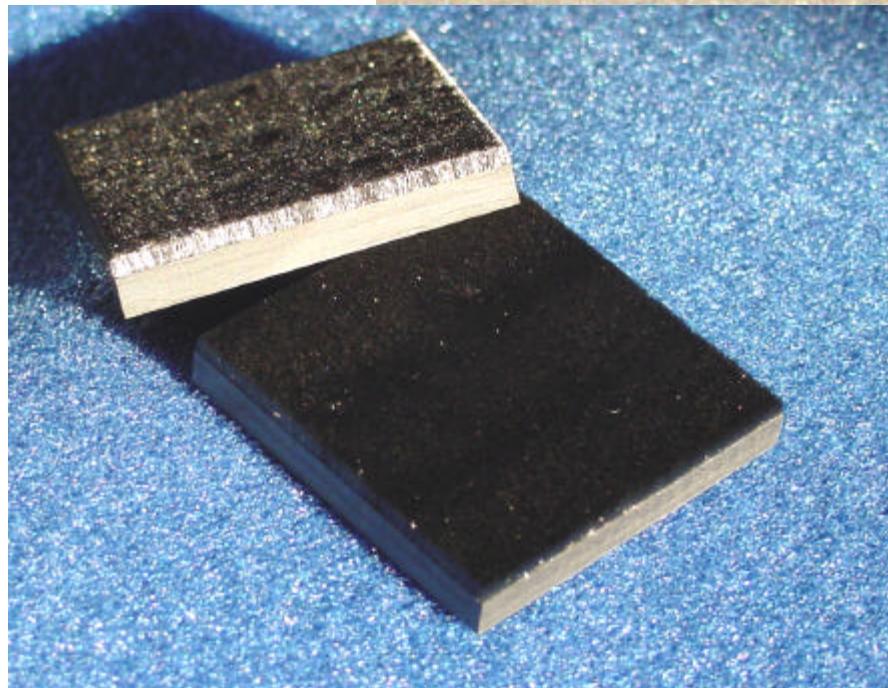
CC Cathodes for PLK (2001)

- High-T processing
 - No outgassing
 - Non-melting
- Carbon-carbon
 - Carbon fiber
 - Carbon adhesive
 - Pyrolyzed, CVD
 - Carbon substrate
 - Pyrocarbon coating



CC Cathodes for NRL (2001)

9-cathode array



ESLI Processing Options

- Materials

- Bondline (epoxy, C, braze)
- Substrate (metal, carbon, ceramic)
- Fiber type (C, glass, SiC, metal, polymer...)
- Surface treatments (CVD, salts, activation)

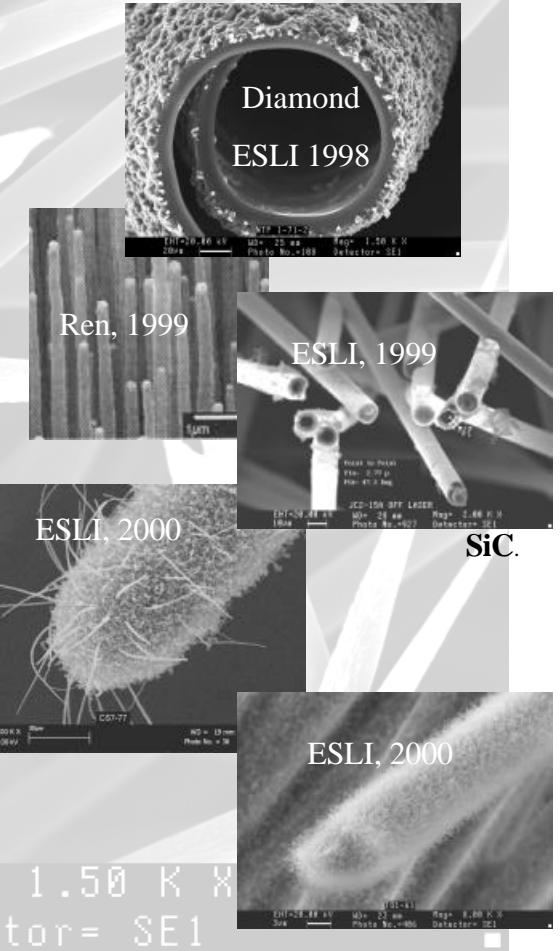
- Texture

- Fiber length, packing density
- Tip shape
- Uniformity of array (random, ordered)
- Uniformity of surface (flat, bimodal)
- Diverse scales (fiber, whisker, nanotube)

EHT=20.00 kV
10 μ m

WD= 31 mm
Photo No.=900

Mag= 1.50 K X
Detector= SEI



Cathode Study - 2001

- Joint effort to better understand explosive emission
 - ESLI prepares cathode configuration
 - Different fiber types, substrates, bondlines, coatings
 - PLK (Ryan Umstattd) measures performance
 - Validate V-I characteristics, closure, uniformity, life
 - Identify & quantify outgassing constituents
- Overall objectives
 - Better understanding of explosive emission
 - Role of ambient gas, cathode vaporization/redeposition
 - Microscopic model?
 - Higher performance electrodes
 - Higher repetition rate, higher average power



POCO Graphite



304 S Steel

Benefits of Carbon

- Clean, conductive, refractory material
 - Cathodes survive 2500°C in vacuum or inert gas
 - Can be coated or infiltrated (eg. molten salts)
- Wide range of configurations
 - Materials and textures (uniformity, order?)
- Can fabricate large-area contoured shapes
 - ESLI fiber handling techniques
 - High-T processing, CVD